

N THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

New York, New York

Tatsufumi KUSUDA

September 5, 2003

Serial No.:

10/621,429

Group Art Unit:

Filed:

July 17, 2003

Examiner:

Date:

For:

THERMAL PROCESSING APPARATUS FOR SUBSTRATE EMPLOYING

PHOTOIRRADIATION

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

SUBMISSION

Sir:

Submitted herewith is a copy of art together with a form listing the same

for the convenience of the Examiner.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents P.O. Box 1450, Alexandria, VA 22313-1450, on September 5, 2003

Respectfully submitted,

Max Moskowitz

Name of applicant, assignee or
Registered Representative

ignature

September 5, 2002

Date of Signature

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MM:cg Enclosures

				Application	10/621,429	OFGS File 1	OFGS File No. P/1250-251			
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 8 609: Draw line through citation if not in conformance a										
not considered. Include copy of this form with next communication to the applicant.										